



NEW ATTORNEY DOCKET NO.: 052640-5031-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Namwoong PAIK et al.) Confirmation No. 5216
Application No.: 10/695,485) Group Art Unit: 1753
Filed: October 29, 2003) Examiner: Unassigned
For: METHOD OF FORMING NON-OXIDE)
THIN FILMS USING NEGATIVE)
SPUTTER ION BEAM SOURCE)

Commissioner for Patents
U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, MS Non-Fee Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

SUPPLEMENTAL PRELIMINARY AMENDMENT

Prior to the examination on the merits of the above-identified application, please amend
the above-identified application as follows: